



WORKSHOP OF PHOTONICS

How to Meet Today's Needs of Those Fabricating Glass in Various Forms?

Novelties in Laser Micromachining Workstations





We deliver **solutions** for **your μ tasks**



18+ years of expertise

in femtosecond laser micromachining
with a high focus on glass



6 in-house and 2 licensed patents

enabling cutting-edge technologies



50+ professionals

5 Ph.D., 30 M.S. and B.S.



R&D studies

continuous projects with
academic and research partners

Members of



ISO certified



wophotonics.com

How we work



HAVE A MICRON CHALLENGE?

A close-up photograph of several white printed circuit boards (PCBs) with various electronic components and traces. The WOP logo is visible on each board.

PROTOTYPING

Rapid prototyping services to test your idea in an actual environment.

A close-up photograph of a circular, perforated metal mesh or filter, showing the fine details of the holes and the material's texture.

PRODUCTION SERVICES

Ultra-high precision services on all materials.

A photograph of a large, white industrial laser system. It features a control panel with a monitor displaying a 3D model of a component, and another monitor showing technical data. The WOP logo is visible on the top of the machine.

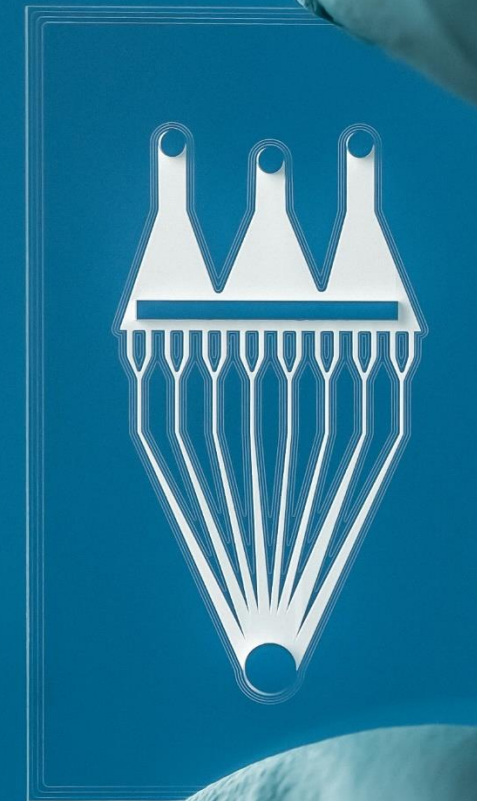
LASER SYSTEM DEVELOPMENT

Tailor-made laser systems designed for your specific application.

All materials: glass, sapphire, ceramics, silicon, metal, plastic, optical fibers.

Market trends

- COVID-19 pandemic motivated investors to transfer major funds to chip diagnostics, as well as at-home diagnosis
- Prototyping and complex microfluidic devices are primarily prototyped in glass
- High potential applications is pushing manufacturers to develop scalable wafer-level processing techniques
- Price per chip pressure urges to look for all-in-one or at least combined production solutions



FemtoGLASS

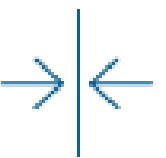
Glass & sapphire cutting workstation for industry - **outperforms** other glass cutting methods

- Ultra-fast thin (30 μm to 3 mm) glass & sapphire cutting
- High process speed – up to 1000 mm/s
- Irregular shapes
- Inner and outer contours
- Easy breaking for non-tempered glass and self-breaking for tempered glass

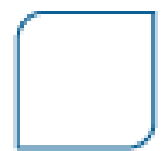
—W O P—



High speed



Thin glass & sapphire



All shapes

Type of glass

- Non-tempered glass
- Tempered glass
- Sapphire

Quality of cuts

- Cut width less than 1 μm
- Ultra-low chipping <10 μm
- No post-processing required

NEW
DESIGN
COMING
SOON!



FemtoFBG

FemtoGLASS

Glass & sapphire cutting workstation
for industry - **outperforms** other glass
cutting methods



Solutions

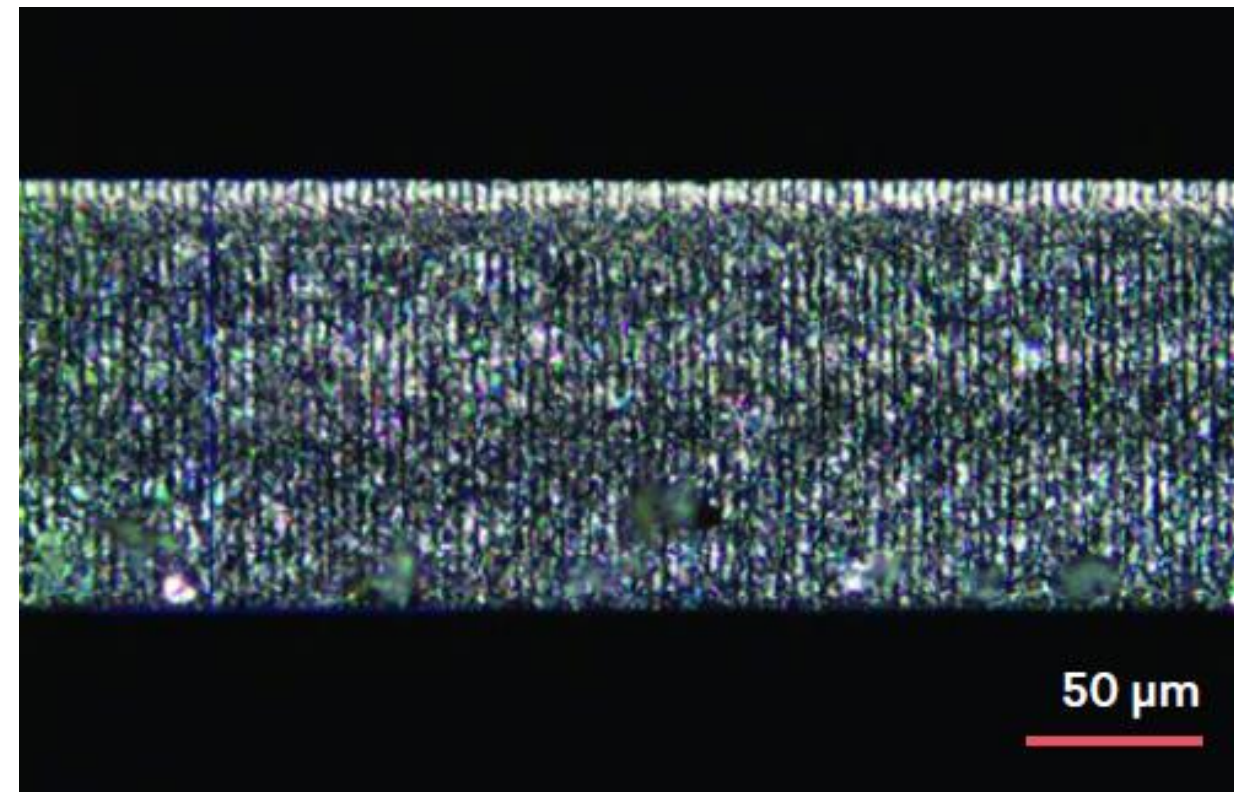
- 8" and 12" industry standards
- Variable material thickness
- Glass dicing combined with chips separation process
- Sample recognition (with and without fiducials)



Glass & sapphire results



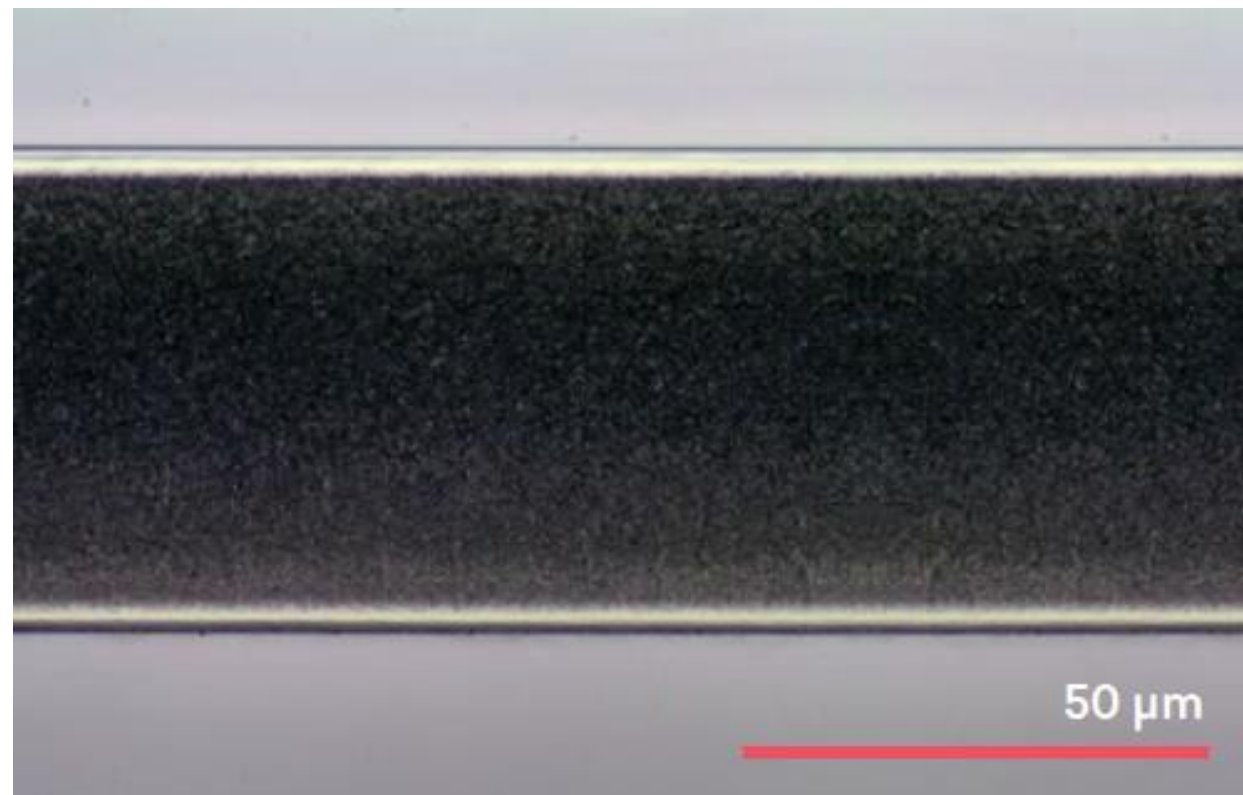
Sapphire 0,6 mm thickness



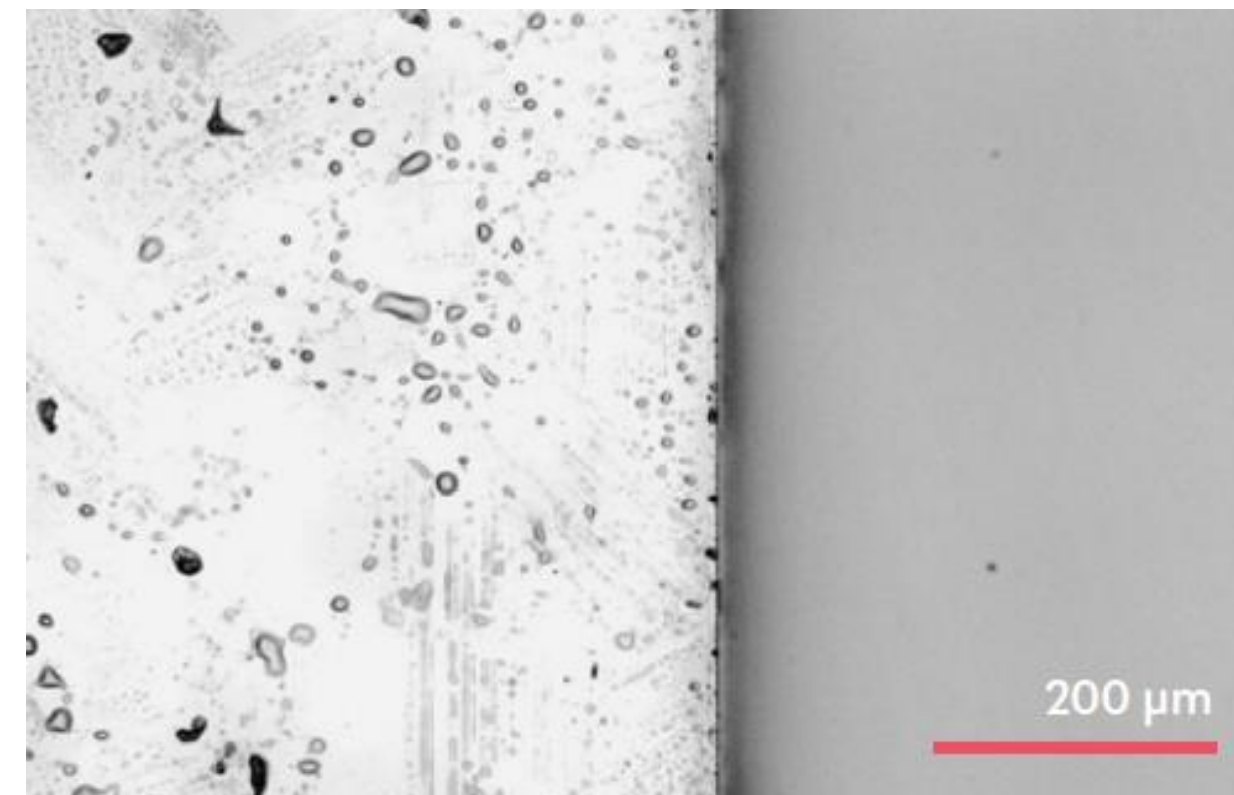
Sapphire 0,1 mm thickness



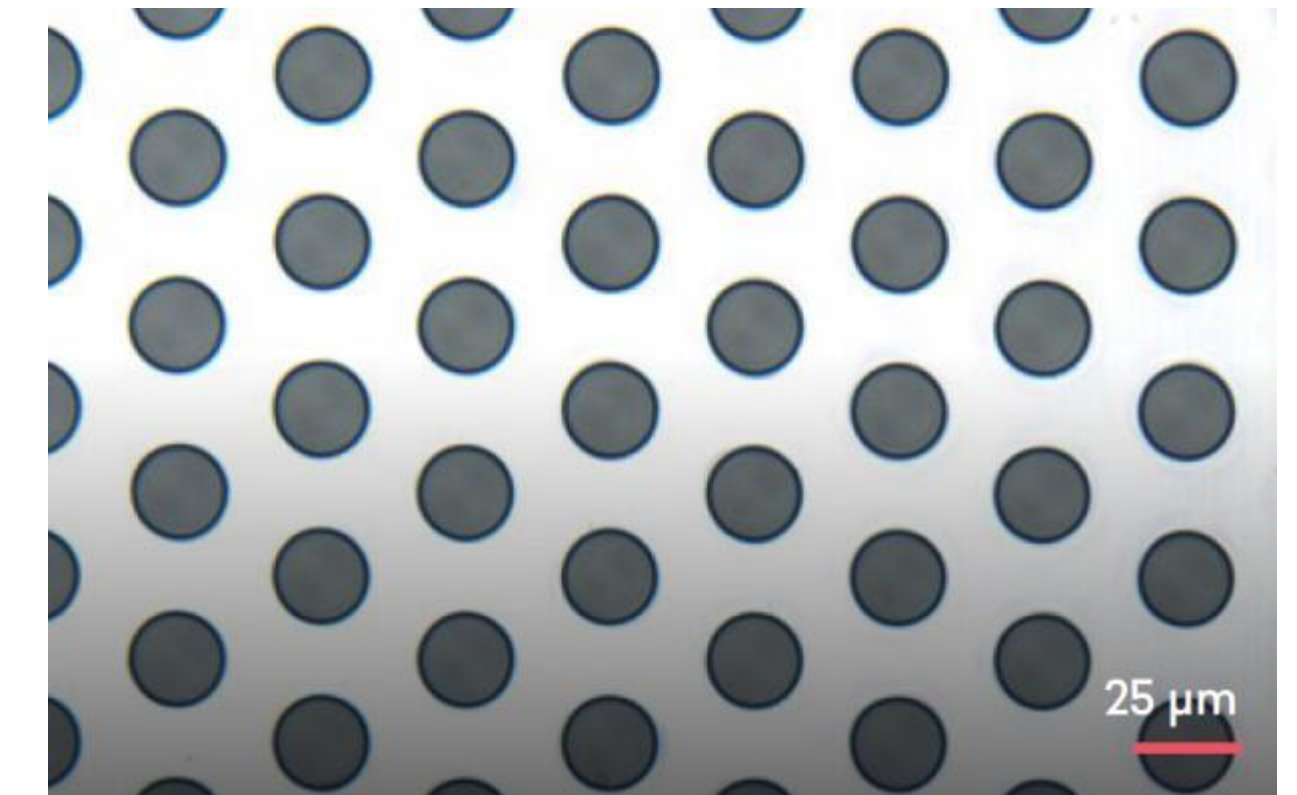
Sapphire 0,6 mm thickness



Tempered glass 0,55 mm thickness



Tempered glass 0,55 mm thickness



Glass wafer drilling

What are the needs?

- Glass is trending because it is ecological, transparent, inert, chemically resistant, biocompatible, etc.
- The industry is looking for ways to change other materials to glass (ex., in semiconductors, silicon to glass)
- There is an increased demand not only in wafer-level glass microfabrication but also in hybrid-layered chips production
- Thin glass micromachining is still a challenge. However, WOP, for the last ten years is heavily investing in developing glass micromachining to overcome these challenges.
- Automated and combined processes



FemtoGLASS

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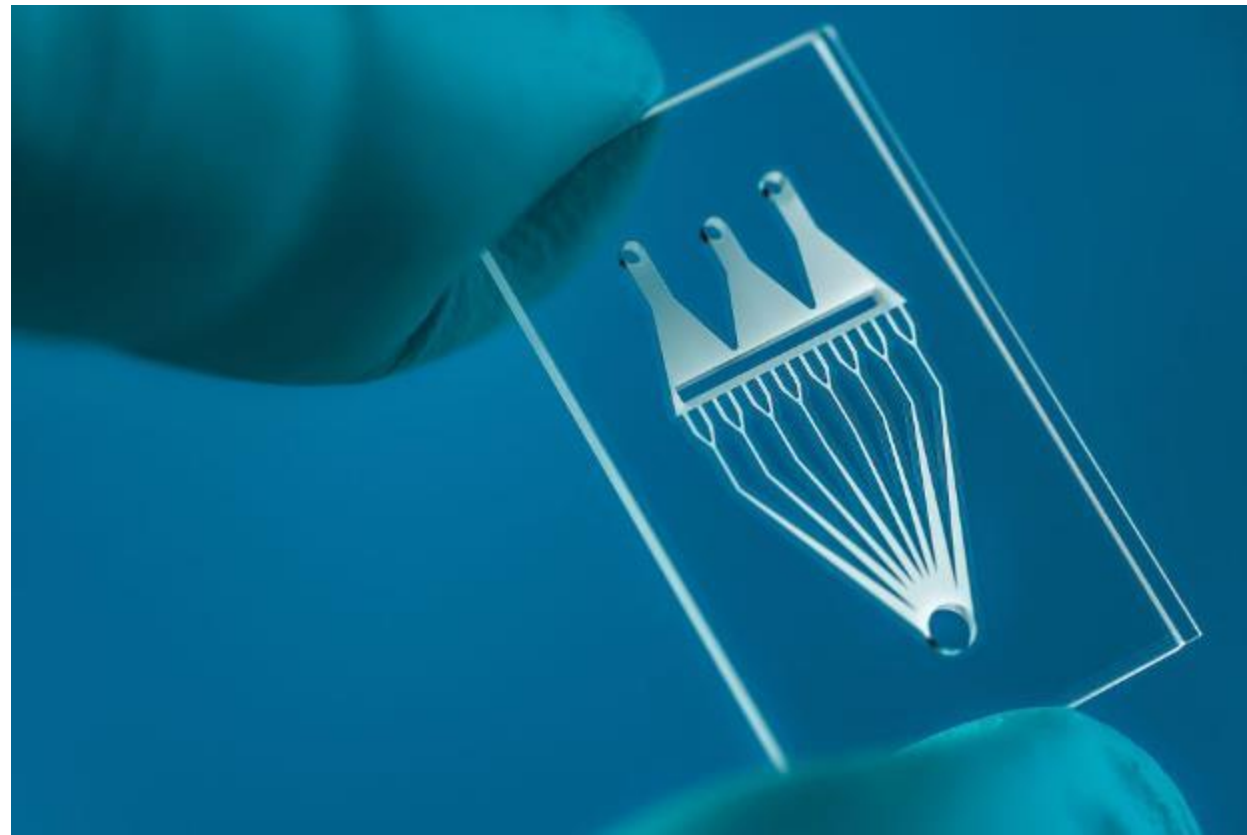
NEW
SOLUTIONS

—W O P—

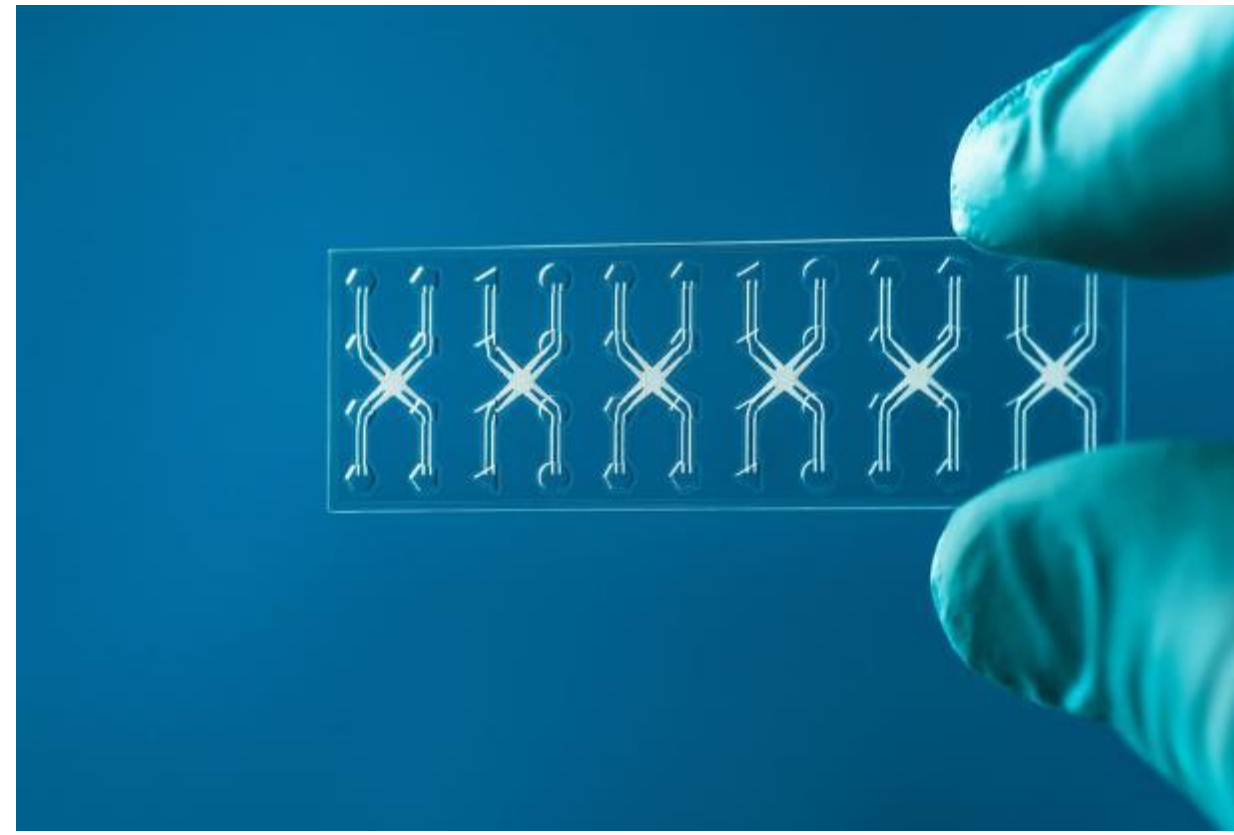
Future needs:

- Integrated marking solution for chips traceability
- Maximum efficiency by automated loading
- Different material layers laser dicing
- Integrated bonding function for truly all-in-one machine design

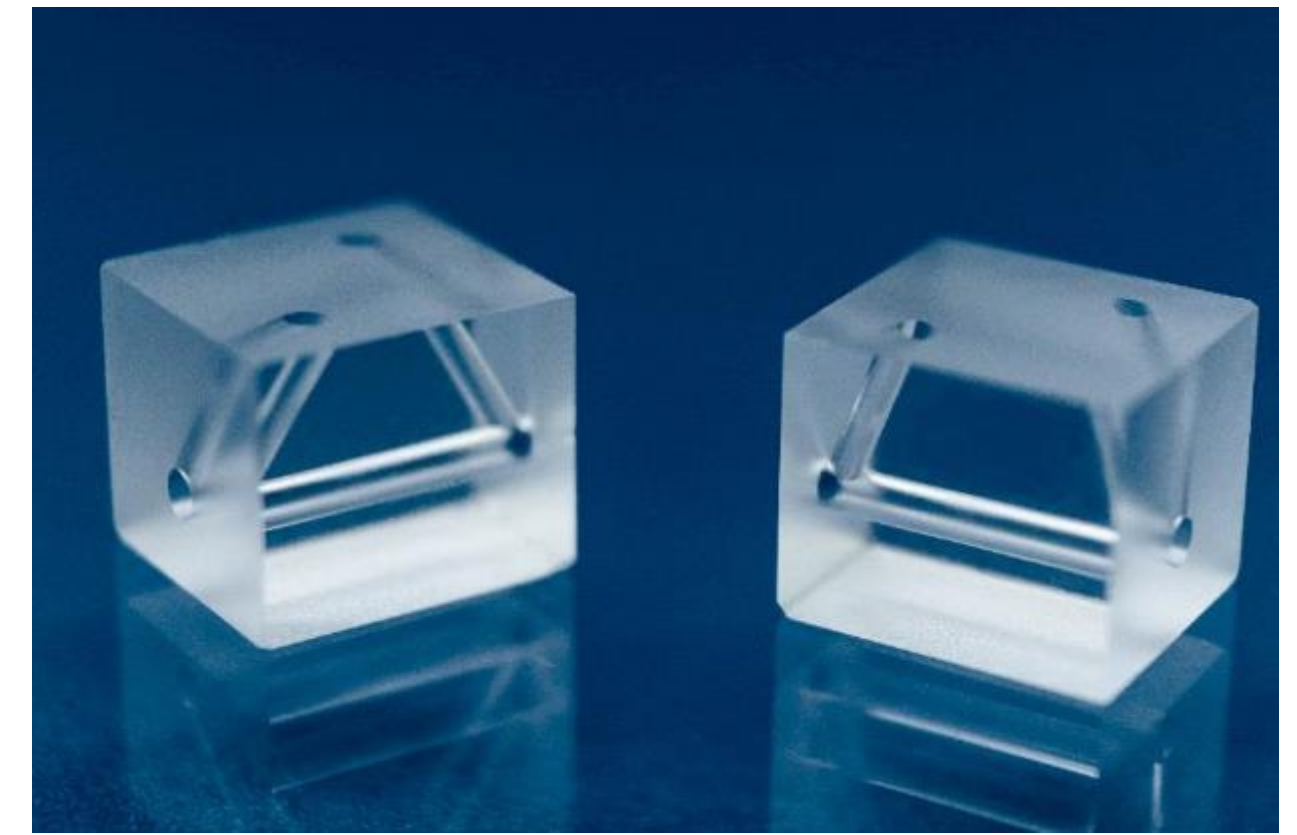
Our recent glass solutions



Custom design microfluidic chips manufacturing



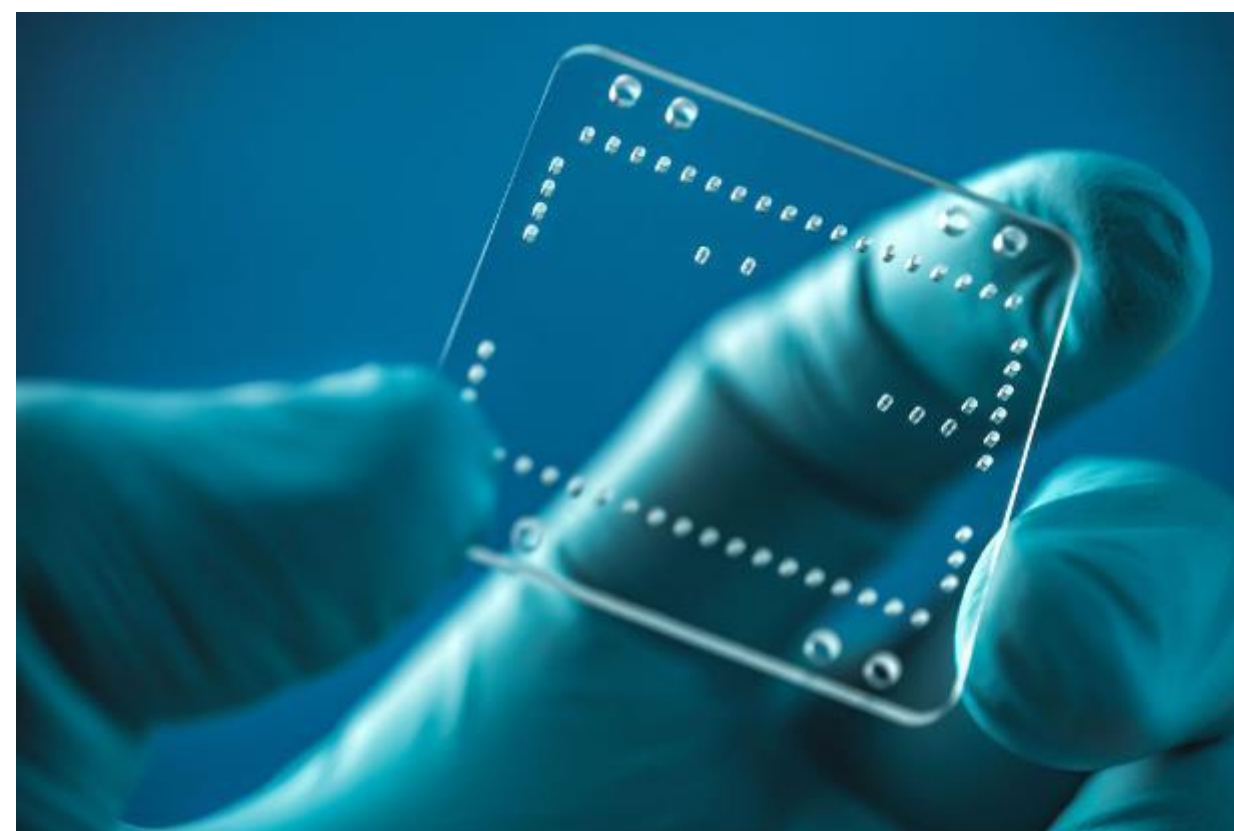
Microfluidic chip bonding up to 5 hermetic layers bonded without adhesive



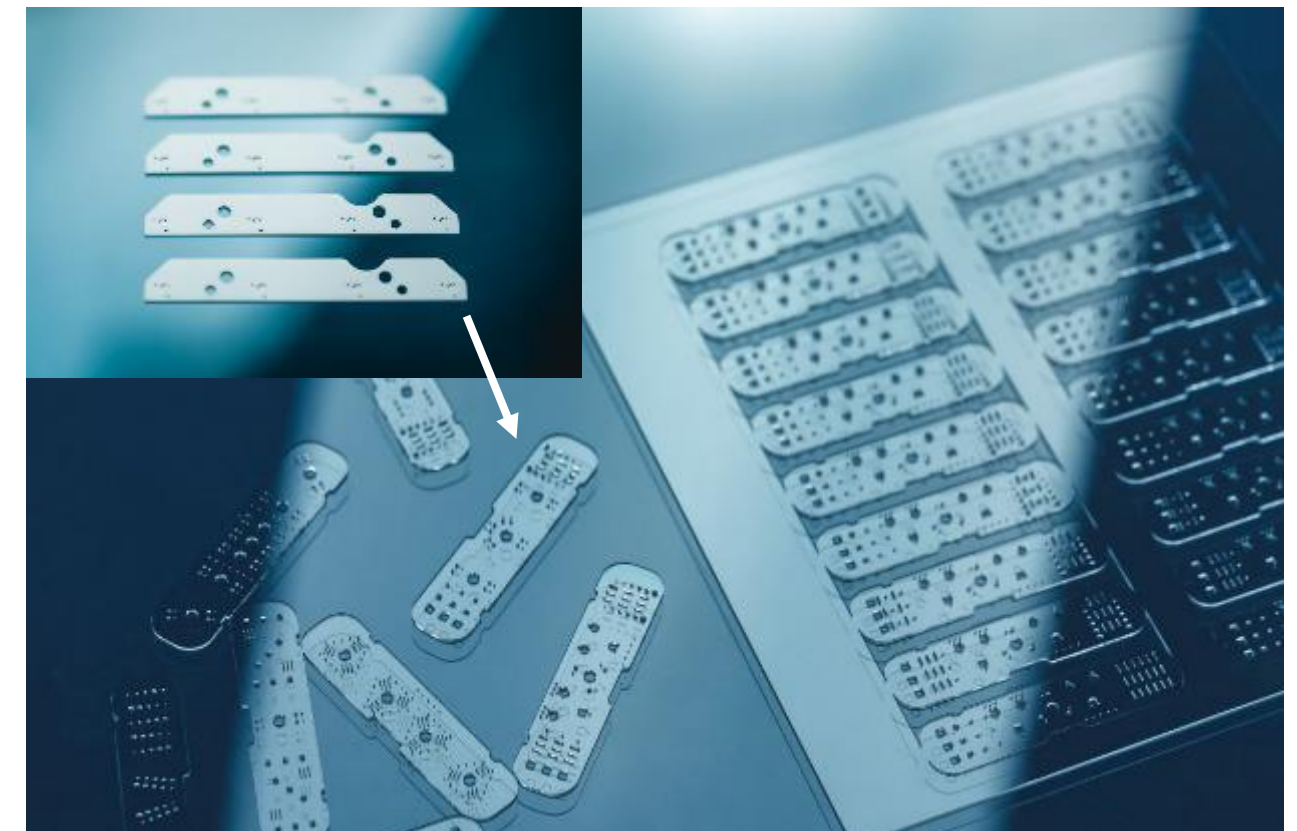
Perfect channels in glass cubes, glass drilling with SLE



Glass wafer Ø 8", 500 μ m thickness, fused silica



Glass probe cards



Switch ceramics to glass for probe cards: 80% less defects and 20x faster processing



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Let us know Your μ tasks –
we will deliver a solution!

www.wophotonics.com

